

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

**INFORMATION DISCLOSURE
STATEMENT**

Docket Number
10020/27902

Application Number
10/607,211

Filing Date
June 25, 2003

Examiner
Not Yet Assigned

Art Unit
1756

Invention Title
THIN FILM ORGANIC POSITION SENSITIVE
DETECTORS

Inventor(s)
FORREST et al.

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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2/12/04

Signature:

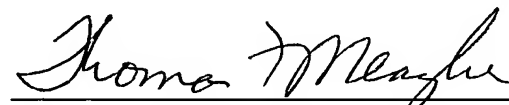

Thomas F. Meagher (Reg. No. 29,831)

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, unless otherwise indicated.
3. It is believed that no fees are due in connection with this Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

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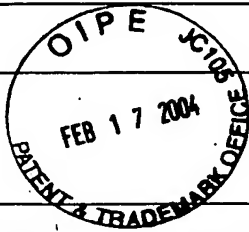
2/12/04

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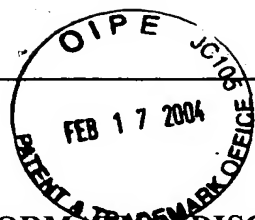
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PTO-1449**

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GROUP
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U. S. PATENT DOCUMENTS

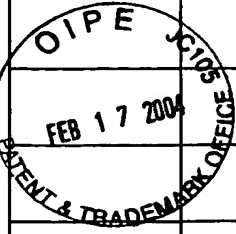
EXAMINER INITIAL	PATENT/ PUBLICATION NUMBER	PATENT/ PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE*
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	5,247,190	September 21, 1993	Friend et al.			
	5,256,205	October 26, 1993	Schmitt, III et al.			
	5,650,197	July 22, 1997	Halpern			
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	2003/0230980	December 18, 2003	Forrest et al.			

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS

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		U.S. Patent Application Serial No. 10/233,470 to Shtein et al., Filed September 4, 2002.
		U.S. Patent Application Serial No. 09/311,126 to Thompson et al., filed May 13, 1999.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	